## AND TRADEMARK OFFI IN THE UNITED STAT

Applicant(s):

BIELLAK, STEVE; STOKOWSKI, STANLEY E.; VAEZ-IRA

**MEHDI** 

Assignee:

KLA-TENCOR TECHNOLOGIES CORPORATION

Title:

SYSTEM AND METHODS FOR A WAFER INSPECTION SYSTEM

USING MULTIPLE ANGLES AND MULTIPLE WAVE

ILLUMINATION

Serial No.:

og 1891 69 3

Filing Date:

June 26

Examiner:

Hao Q. Pham

Group Art Unit:

2877

Docket No.:

M-10693 US

San Jose, California July 24, 2002

**BOX FEE AMENDMENT** 

COMMISSIONER FOR PATENTS FICE OF THE

Washington, D. C. 20231

Dear Sir:

MISSIONER FOR PATENTSFICE OF THE SPECIAL INCOME.

PROGRAMS EXAMINER

PETITION FOR EXTENSION OF TIME

OF THE SPECIAL INCOME.

PETITION FOR EXTENSION OF TIME

OF THE SPECIAL INCOME.

Applicants respectfully petitions for a three-month extension of time within which to respond to the January 24, 2002 outstanding Office Action, such extension allowing the CDILINGCOD ECTRONAL DECU

undersigned until July 24, 2002 to respond.

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Please charge the amount of \$920.00 as set forth in the enclosed transmittal letter.

**EXPRESS MAIL LABEL NO.:** 

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Respectfully submitted,

Attorney for Applicant(s)

Reg. No. 29,545

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